

**Amendments to the Claims:**

This listing of claims is provided for the Examiner's convenience. No claim amendment has been made.

**Listing of Claims:**

1. (Original) A method to singulate a circuit die from an integrated circuit wafer, said method comprising:  
providing an integrated circuit wafer containing a circuit die;  
cutting through said integrated circuit wafer by performing a single, continuous cut around the perimeter of said circuit die to thereby singulate said circuit die.
2. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a non-rectangular perimeter.
3. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a perimeter having rounded corners.
4. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a perimeter having more than four sides.
5. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a perimeter having three sides.
6. (Original) The method according to Claim 1 wherein said singulated circuit die comprises an elliptical perimeter.
7. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a circular perimeter.
8. (Original) The method according to Claim 1 wherein said step of cutting through is performed using a laser.

9. (Original) The method according to Claim 1 wherein said step of cutting through is performed using an electron beam or water jet.

10. (Original) The method according to Claim 1 further comprising:  
fixably mounting said singulated circuit die onto a package; and  
coupling signal pins of said package to signals in said electronic circuit.

11. (Original) A method to singulate a circuit die from an integrated circuit wafer, said method comprising:

providing an integrated circuit wafer containing a circuit die;  
cutting through said integrated circuit wafer by performing a single, continuous cut around the perimeter of said circuit die to thereby singulate said circuit die and wherein said singulated circuit die comprises a non-rectangular perimeter;  
fixably mounting said singulated circuit die to package; and  
coupling signal pins of said package to signals in said electronic circuit.

12. (Original) The method according to Claim 11 wherein said non-rectangular perimeter has rounded corners.

13. (Original) The method according to Claim 11 wherein said non-rectangular perimeter more than four sides.

14. (Original) The method according to Claim 11 wherein said non-rectangular perimeter has three sides.

15. (Original) The method according to Claim 11 wherein said non-rectangular perimeter is an ellipse.

16. (Original) The method according to Claim 11 wherein said non-rectangular perimeter is a circle.

17. (Original) The method according to Claim 11 wherein said step of cutting through is performed using a laser.

18. (Original) The method according to Claim 11 wherein said step of cutting through is performed using an electron beam or a water jet.

19. (Currently Amended) A method to singulate a circuit die from an integrated circuit wafer, said method comprising:

providing an integrated circuit wafer containing a circuit die;

providing a first cut partially cutting through said integrated circuit wafer on a first part of the perimeter of said circuit die using a focused beam apparatus; and

providing a second cut cutting through said integrated circuit wafer on a second part of said perimeter of said circuit die using a wafer saw blade apparatus ~~to thereby singulate said circuit die[.];~~

wherein at least one of the first and second cut is performed by a single continuous cut around the perimeter of said circuit die.

20. (Original) An integrated circuit device comprising:  
a semiconductor substrate containing an electronic circuit wherein said semiconductor substrate has a non-rectangular perimeter; and  
a package comprising:

a surface to fixably mount said semiconductor substrate;

a plurality of signal pins; and

a means of coupling said signal pins to signals in said electronic circuit.

21. (Original) The device according to Claim 20 wherein said non-rectangular perimeter has rounded corners.

22. (Original) The device according to Claim 20 wherein said non-rectangular perimeter has more than four sides.

23. (Original) The device according to Claim 20 wherein said non-rectangular perimeter has three sides.

24. (Original) The device according to Claim 20 wherein said non-rectangular perimeter is an ellipse.

25. (Original) The device according to Claim 20 wherein said non-rectangular perimeter is an "L" shape, an "H" shape, a "T" shape, or a curved shape.